

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
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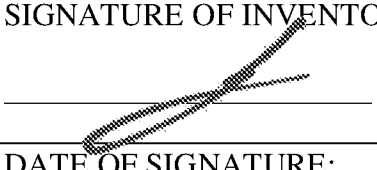
EPAS ID: PAT7102092

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
AMOS FENIGSTEIN	12/22/2021
TOMER LEITNER	12/23/2021
RECEIVING PARTY DATA	
Name:	TOWER SEMICONDUCTOR LTD.
Street Address:	RAMAT GABRIEL INDUSTRIAL PARK, P.O. BOX 619
City:	MIGDAL HAEMEK
State/Country:	ISRAEL
Postal Code:	23105
PROPERTY NUMBERS Total: 1	
Property Type	Number
Patent Number:	8779543
CORRESPONDENCE DATA	
Fax Number:	(703)683-4707
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
Phone:	7038385568
Email:	ErinGeraghty@geraghtyipservices.com
Correspondent Name:	RECHES PATENT
Address Line 1:	211 NORTH UNION STREET, SUITE 100
Address Line 4:	ALEXANDRIA, VIRGINIA 22314
ATTORNEY DOCKET NUMBER:	8213-US
NAME OF SUBMITTER:	ERIN D. GERAGHTY
SIGNATURE:	/Erin D. Geraghty/
DATE SIGNED:	01/03/2022
Total Attachments: 2	
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source=8213-US-Assignment-Tower2#page1.tif	

ASSIGNMENT AND AGREEMENT

FOR good and valuable consideration, the receipt of which is hereby acknowledged, we, Amos Fenigstein residing at 63 Hatichon Street, 3229306 Haifa, Israel; Tomer Leitner residing at 6 Raich Shimon Street, 2240203 Nahariya, Israel; have sold, assigned and transferred, and do hereby sell, assign and transfer, unto Tower Semiconductor Ltd. corporation having its principal place of business at Ramat Gabriel Industrial Park, P.O. Box 619, Migdal Haemek, 23105, Israel; and its successors, assigns, and legal representatives, the entire right, title and interest in US Patent 8,779,543 grant date 7/15/2014 and is entitled DEVICE HAVING AN AVALANCHE PHOTO DIODE AND A METHOD FOR SENSING PHOTONS

Together with the entire right, title and interest in and to the application, and in and to Letters Patent which may be issued upon the application, and upon any division, extension, continuation or reissue thereof or any foreign patent application which claims priority from the application;

FULL NAME OF INVENTOR: Amos Fenigstein	FULL NAME OF WITNESS: _____
SIGNATURE OF INVENTOR: 	SIGNATURE OF WITNESS: _____
DATE OF SIGNATURE: 22.12.21	ADDRESS OF WITNESS: _____

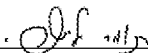
FULL NAME OF INVENTOR: Tomer Leitner	FULL NAME OF WITNESS: _____
SIGNATURE OF INVENTOR: _____	SIGNATURE OF WITNESS: _____
DATE OF SIGNATURE: _____	ADDRESS OF WITNESS: _____

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FULL NAME OF INVENTOR: Amos Fenigstein	FULL NAME OF WITNESS: _____
SIGNATURE OF INVENTOR: _____	SIGNATURE OF WITNESS: _____
DATE OF SIGNATURE: _____	ADDRESS OF WITNESS: _____

FULL NAME OF INVENTOR: Tomer Leitner	FULL NAME OF WITNESS: _____
SIGNATURE OF INVENTOR:  _____	SIGNATURE OF WITNESS: _____
DATE OF SIGNATURE: 23/12/2021 _____	ADDRESS OF WITNESS: _____